

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ricky Amos, et al. **Examiner:** Matthew C. Landau
Serial No: 09/995,031 **Art Unit:** 2815
Filed: November 29, 2001 **Docket:** YOR920010633US1 (19031)

For: HIGH TEMPERATURE PROCESSING COMPATIBLE METAL GATE ELECTRODE
FOR pFETs AND METHOD FOR FABRICATION

Confirmation No: 9669 **Dated:** July 24, 2007

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RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

In response to the Office Action dated April 25, 2007, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on July 24, 2007.

Dated: July 24, 2007


Leslie S. Szivos, Ph.D.